

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yoshihito NARITA et al.



Application No.: 10/076,302

Filed: February 19, 2002

Docket No.: 111733

For: FILTER, PROBE AND OPTICAL HEAD OF MULTIPLE OPTICAL PATH ARRAY TYPE
AND METHODS FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT

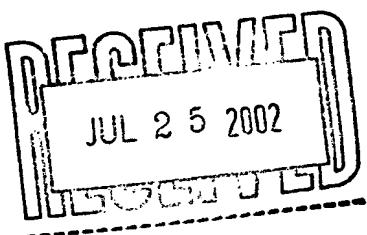
Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. English-language Abstracts of the non-English language references 1-3 are attached hereto.

Respectfully submitted,



James A. Oliff
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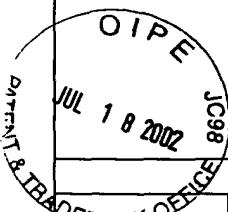
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Date: July 18, 2002

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 111733		APPLICATION NO. 10/076,302	
INFORMATION DISCLOSURE STATEMENT							
(Use several sheets if necessary)							
 O I P E JUL 18 2002 JC98							
APPLICANTS Yoshihito NARITA et al.							
FILING DATE February 19, 2002							
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLASS	SUB CLASS
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUB CLASS
	1	JP A 2000-215499 (w/abstract)	08/04/2000	Japan			
	2	JP A 2000-132856 (w/abstract)	05/12/2000	Japan			
	3	JP A 2000-223767 (w/abstract)	08/11/2000	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
	4	Yatsui et al., "Subwavelength-sized phase-change recording with a silicon planar apertured probe", SPIE, Vol. 3791, pages 76-84, July 1999					
	5	Lee et al., "Nanometric aperture arrays fabricated by wet and dry etching of silicon for near-field optical storage application", J. Vac. Sci. Technol. B, Vol. 17, Number 6, pages 2462-2466, Nov/Dec 1999					
	6	Yatsui et al., "High-density-speed optical near-field recording-reading with a pyramidal silicon probe on a contact slider", OPTICS LETTERS, Vol. 25, No. 17, pages 1279-1281, September 2000					
EXAMINER					DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							